



In re Application of: **Takahiro ORNAKADO**  
 Application No. **09/911,581**  
 Filed: **July 25, 2001**  
 For: **SI-MOS HIGH-FREQUENCY SEMICONDUCTOR DEVICE AND THE MANUFACTURING METHOD OF  
 THE SAME**

**COMMISSIONER FOR PATENTS**  
 Washington, D.C. 20231

Sir:

Transmitted herewith is a response to an office action in the subject application.

Applicants claim small entity status of this application under 37 CFR 1.27.

**Petition for Extension of Time**

Applicants petition for a one-month extension of time under 37 CFR 1.136, the fee for which is \$110.00 (enclosed).

Applicants believe that no petition for an extension of time is necessary. However, to the extent that such petition is deemed necessary, Applicants hereby petition for a sufficient extension of time to render the present submission timely. Please charge Deposit Account No. 12-1216 for the appropriate petition fee.

No additional claim fee is required.

Other:

The claim fee has been calculated as shown below:

		CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NUMBER PREVIOUSLY PAID FOR	EXTRA CLAIMS PRESENT	SMALL ENTITY		OTHER THAN A SMALL ENTITY	
TOTAL					MINUS	=	RATE	ADDT. CLAIM FEE
INDEPENDENT					MINUS	=	x 42=	\$
<input type="checkbox"/>	<b>FIRST PRESENTATION OF MULTIPLE CLAIM</b>						x 9=	\$
							x 18=	\$
							x 84=	\$
							+ 140=	\$
							+ 280=	\$
							TOTAL	\$
							TOTAL	\$

Please charge my Deposit Account No. 12-1216 in the amount of \$ . A duplicate copy of this sheet is attached.

A check in the amount of \$ is attached.

The Commissioner is hereby authorized to charge any deficiencies in the following fees associated with this communication or credit any overpayment to Deposit Account No. 12-1216. A duplicate copy of this sheet is attached.

Any filing fees under 37 CFR 1.16 for the presentation of extra claims.

Any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

Jeffrey A. Wyand, Reg. No. 29,458  
 LEYDIG, VOIT & MAYER  
 700 Thirteenth Street, N.W., Suite 300  
 Washington, DC 20005-3960  
 (202) 737-6770 (telephone)  
 (202) 737-6776 (facsimile)

Date: October 28/2002  
 JAW/tph  
 Amendment or ROA Transmittal (Revised 9/10/02)



#7/Election  
& B

10/30/02

PATENT

Attorney Docket No. 401308/ASAHIWA

maleshi

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

Takahiro OHNAKADO

Application No. 09/911,581

Art Unit: 2815

Filed: July 25, 2001

Examiner: N Drew Richards

For: SI-MOS HIGH-FREQUENCY  
SEMICONDUCTOR DEVICE AND THE  
MANUFACTURING METHOD OF THE  
SAME

RECEIVED  
TECHNOLOGY CENTER 2800  
OCT 29 2002

**RESPONSE TO OFFICE ACTION**

Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

In response to the Office Action dated October 1, 2002, please enter the following amendments and consider the following remarks.

**AMENDMENTS**

*IN THE TITLE:*

✓  
Replace the title with:

**SI-MOS HIGH-FREQUENCY SEMICONDUCTOR DEVICE**